A Novel Approach for Accelerated Fabrication of Calcium Hydroxyapatite Thin Films

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In this study we demonstrate, that sol–gel route is suitable to quicker obtain calcium hydroxyapatite (Ca_{10}(PO_{4})_{6}(OH)_{2}, CHAp) coatings on crystalline Si substrate by modified dip-coating technique. The substrate was dip-coated by precursor and dried for 10 minutes at 200 °C with following cooling using the heating block for 110 min and annealing at 650 °C. Ethylenediaminetetraacetic acid and 1,2-ethandiol, and triethanolamine and polyvinyl alcohol were used as complexing agents and as gel network forming agents, respectively. The obtained coatings were characterized by X-ray diffraction (XRD) analysis, scanning electron microscopy (SEM), FTIR spectroscopy and contact angle measurements (CAM).

Keywords: hydroxyapatite, sol–gel, dip–coating, thin film.

1. INTRODUCTION

Engineering of biomaterials is a growing field that focuses on the development of materials to replace or augment human tissues [1]. Orthopedic and dental implants are medical devices manufactured to replace a missing joint or bone or to support a damaged bone [2]. The medical implants are mainly fabricated using stainless steel and titanium alloys [1, 3]. As the metal implants should stay in the human body for a long time, they should not have drawbacks like corrosion or dissolution and toxic ion release.

Many different techniques are being used to synthesize Calcium Hydroxyapatite (CHAp) coatings on the substrate [4]. Plasma spraying is the only one approved by the Food and Drug Administration (FDA) [5]. This method is being criticized because of its expensive equipment, use of high temperatures, which may cause degradation on CHAp and difficulty in controlling coating quality and adhesion [6]. Dip-coating, combined with sol-gel processing in an inexpensive and simple process, that can be carried out with simple equipment. This method allows to mass produce coating on various size and shape substrates and the parameters can be controlled through sol-gel concentration, withdrawal speed and annealing temperatures. Also, high purity and homogeneity can be achieved. On the other hand, annealing temperatures are usually high and coating is brittle [7–9].

In this study we combined dip-coating with sol-gel processing to produce quicker CHAp films on silica substrate. Drying step was introduced into dip-coating process that made this process less time consuming.

2. EXPERIMENTAL DETAILS

To prepare CHAp films, calcium acetate monohydrate was used as calcium source. To the aqueous solution of Ca(CH_{2}COO)_{2} the 1,2-ethandiol was added. The obtained mixture was stirred for 30 min at 65 °C. Then ethylenediaminetetraacetic acid was added, and after 15 min triethanolamine (TEA) was slowly added. The solution was stirred for 10 h. Then diluted orthophosphoric acid was added (Ca/P ratio was 1.67). Finally, this solution was mixed by ratio 5:3 with PVA dissolved in distilled water [10, 11]. All crystalline Si substrates were cleaned in an ultrasonic bath with acetone, ethanol and distilled water sequentially. One dip-coating cycle consisted of dipping the substrate and retrieving it, drying for 10 min at 200 °C in dip-coater dryer and leaving for 110 min. The procedure was repeated 5 times. After that, samples were heated at 650 °C for 5 h using the heating rate of 1 °C/min. The samples were cooled to the room temperature within the furnace. The formation of coatings on silicon substrate was performed using a dip-coater (Holmarc HO-TH-02B). The dipping rate of substrate was 85 mm/min and lifting rate was 40 mm/min. The substrate was left in the gel solution for 20 s.

The coatings were characterized by X-ray diffraction (XRD, Rigaku MiniFlex II) analysis, scanning electron microscopy (SEM, Hitachi SU 70) and contact angle measurements (KSV Instrument CAM 100). FTIR spectra were recorded in transmission mode by using FTIR spectrometer ALPHA (Bruker, Inc.), equipped with a room temperature detector DLATGS. Spectra were acquired from 100 interferogram scans with 2 cm⁻¹ resolution.

Blank Si substrate after 6 cycles (without coating) was used as a reference sample.
3. RESULTS AND DISCUSSION

The XRD results of CHAp coatings obtained by accelerated procedure are presented in Fig. 1. The XRD patterns of CHAp films on silica substrate show the formation of CHAp phase already after 1 coating cycle (5 dips).

SEM micrographs of the CHAp coatings are presented in Fig. 2. As seen, a smooth homogenous surface with small grains is obtained after 1 coating cycle. After 3 coating cycles, the surface is rougher, with bigger grains and few cracks. This might be caused by thermal expansion mismatch between the coating and the substrate. This more perfect microstructure could be obtained by controlling the cooling procedure. The final sample, obtained after 6 coating cycles contains the biggest grains due to the increased number of annealing procedures. The SEM results are in a good agreement with the results of contact angle measurements. After the initial coating, the contact angle increased from 67° (blank sample) to 85°. With the increasing number of coating cycles, the contact angle decreased due to the existence of cracks on the surface and higher porosity.

![Fig. 1. XRD patterns of CHAp films on silica substrate. Diffraction peaks: • (Ca₁₀(PO₄)₆(OH)₂) (PDF: 74-0566); ♦ - Si](image1.png)

![Fig. 2. SEM micrographs of CHAp coatings obtained on silica: a–1, b–3; c–6 coating cycles; d–blank sample](image2.png)

Fourier transform infrared (FTIR) spectroscopy in transmission mode revealed that free PO₄³⁻ ion belongs to tetrahedral (T₄) symmetry and its vibrational spectrum consists from four modes; Raman-active totally symmetric stretching ν₁ (A₁), Raman-active double degenerate symmetric deformation ν₂ (E), both infrared- and Raman-active triply degenerate asymmetric stretching ν₃ (F₂), and both infrared- and Raman-active triply degenerate asymmetric deformation ν₄ (F₂) vibrational modes [12–15]. Fig. 3 compares FTIR spectra of different CHAp layers on Si substrate. Peak positions and assignments of the bands are listed in Table 1. Peak positions of the PO₄³⁻ coincide well with hydroxyapatite structure [16–18]. In the high frequency region, the sharp band due to O–H stretching vibrations of OH⁻ ion is visible at 3571 cm⁻¹, thus confirming presence of the hydroxyapatite crystal lattice. The width of ν(OH) band determined as full width at half maximum (FWHM) was found to be 15.5 cm⁻¹ for 6 cycles sample. This value is slightly large comparing with previously reported values for crystalline hydroxyapatite (6–12 cm⁻¹) [19]; however, is considerable lower comparing with calcium hydroxyapatite film on Si₃N₄ substrate (70.3 cm⁻¹) [20].

The relative amount of carbonate ions was evaluated by analysis of integrated intensity ratios A(CO₃²⁻)/A(PO₄³⁻) (Table 1). One can see that relative amount of carbonate slightly increases with decreasing number of deposited layers. The relative amount of hydroxyl ion remains similar for all studied samples. Importantly, the hydroxyapatite structure is preserved even for very thin (1 cycle ≈ 5 dips) coating on Si, as clearly visible from the presence of ν(OH) peak near 3570 cm⁻¹ (Fig. 3).

![Fig. 3. FTIR absorbance spectra of annealed (650 °C, 5 h) CHAp films on Si substrate: a–6 cycles, b–5 cycles; c–3 cycles; d–1 cycle](image3.png)

4. CONCLUSIONS

Calcium hydroxyapatite (CHAp, Ca₁₀(PO₄)₆(OH)₂) thin layers were fabricated from Ca-P-O sol-gel solution on silicon (Si) substrate using improved dip-coating method. This suggested technique allowed to achieve desired results 4 times faster in comparison with previously suggested processing. XRD results confirmed the formation of CHAp as single phase after annealing of coatings in air atmosphere at 650 °C for 5 h.
The spectroscopic data also indicated the presence of ordered crystalline structure of hydroxyapatite film. SEM micrographs of the CHAp surfaces revealed the formation of smooth and homogenous coatings with small grains. The SEM results were in a good agreement with the results of contact angle measurements.

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